

PATENT
Attorney Docket
542-007-4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Matsubara

Serial No.: To be assigned

Filed: herewith

Title: METHOD FOR MANUFACTURING TFT ARRAY SUBSTRATE OF LIQUID
CRYSTAL DISPLAY DEVICEAssistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Kindly enter the following Amendment and Remarks in this
application before examination.

PRELIMINARY AMENDMENTIn the claims:

Please amend claims 4 through 14 as follows:

4. A method for manufacturing a TFT array substrate
according to claim 1 wherein a ITO film is further formed, and
through patterning to selectively remove the ITO film, the ITO
film on the source line is left to form the ITO film covering the
source line.

5. A method for manufacturing a TFT array substrate in
which as least (a) a gate insulating film, (b) a semiconductor
layer and (c) a metal layer are sequentially formed in this order